

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **ALEXANDER
BIETSCH, ET AL.**

Serial No.: **10/787,476**

Filed: **26 FEBRUARY 2004**

For: **SYSTEM, METHOD, AND
APPARATUS FOR MULTILEVEL UV
MOLDING LITHOGRAPHY FOR AIR
BEARING SURFACE PATTERNING**

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Attorney Docket No.: **HSJ920030074US1**

Examiner: **EMMANUEL S. LUK**

Confirmation No.: **6992**

Art Unit: **1722**

AMENDMENT A

MAIL STOP – Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mr. Luk:

This Amendment is submitted in response to the Office Action dated June 29, 2006, with a shortened statutory period ending on September 29, 2006. Please amend the above-identified application as follows:

CERTIFICATE OF EFS-Web FILING	
I hereby certify that this paper is being submitted via the PTO Electronic Filing System to Addressee on the date indicated below and is addressed to Commissioner for Patents – Filing Receipt Corrects.	
Date of Submission	By:
8/23/06	